

Docket No.: 52352-785

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

George Jonathan KLUTH

Serial No.: Unassigned

Group Art Unit: Unassigned

Filed: Concurrent Herewith

METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH

SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE

Examiner: Unassigned

CONTACTS

PRELIMINARY AMENDMENT

Commissioner for Patents Washington, DC 20231

Sir:

For:

Prior to examination of the above-referenced application, please amend the application as

follows:

IN THE SPECIFICATION:

Page 1, after the title, please insert the following subsection:

-- RELATED APPLICATIONS

This application claims priority from U.S. Provisional Application Serial No. 60/267,407,

filed February 9, 2001, incorporated herein by reference.--

REMARKS

Entry of this preliminary amendment is respectfully requested.

Respectfully submitted,

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